

## **EXPRESS MAIL NO.: EV 346 793 865 US**

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Bruno GHYSELEN et al.

Confirmation No. 9064

Application No: 10/637,094

Group Art Unit: 2812

Filing Date: August 6, 2003

Examiner: Thanh V. Pham

For: METHOD AND APPARATUS FOR ADJUSTING THE THICKNESS OF A LAYER

OF SEMICONDUCTOR MATERIAL

Atty. Docket No.: 4717-6300

## **AMENDMENT**

Commissioner for Patents P.O. Box 1450 Alexandria, Virginia 22313-1450

Sir:

This communication responds to the Office Action dated May 3, 2005, concerning the above-identified application.

Amendments to the claims begin on page 2.

Remarks begin on page 6 of this paper.

A petition for an extension of time for one month from August 3, 2005 to September 3, 2005 is filed concurrently herewith. No additional fee is believed due with this Amendment. Please charge any fee deemed necessary (and refund any overpayments) to Winston & Strawn, LLP Deposit Account No. 50-1814.

so vilas